

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroshi CHIBA

Application No.: Rule 53(b) Continuation of 10/346,082 filed January 17, 2003

Filed: April 22, 2004

Docket No.: 104685.05

For: METHOD FOR ADJUSTING PROJECTION OPTICAL APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. The present application was filed or entered the U.S. National Stage of the PCT after June 30, 2003. In accordance with the June 11, 2003, Notice waiving the requirements of 37 CFR §1.98(a)(2)(i), copies of any U.S. patents and patent application publications are not attached.
- 3. The references were cited by or submitted to the Office in parent application No. 10/346,082, filed January 17, 2003, which is relied upon for an earlier filing date under 35 U.S.C. §120. Thus, copies of these references are not attached. 37 CFR §1.98(d).

Respectfully submitted,



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MAC/ccs

Date: April 22, 2004

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<b>DEPOSIT ACCOUNT USE AUTHORIZATION</b> Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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Form PTO-1449 (REV. 8-83)	US Dept. of Commerce PATENT & TRADEMARK OFFICE	ATTY DOCKET NO. 104685.05	APPLICATION NO. Rule 53(b) Continuation of 10/346,082 filed January 17, 2003
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)		APPLICANT(S) Hiroshi CHIBA	
		FILING DATE April 22, 2004	GROUP

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	3,583,790	06-1971	Baker		
	4,883,345	11-1989	Anzai et al.		
	4,888,614	12-1989	Suzuki et al.		
	4,259,004	03-1981	Tateoka et al.		
	4,730,900	03-1988	Uehara et al.		
	4,965,630	10-1990	Kato et al.		
	5,095,386	03-1992	Scheibengraber		
	5,117,255	05-1992	Shiraishi et al.		
	5,260,832	11-1993	Togino et al.		
	5,309,198	05-1994	Nakagawa		
	5,350,924	09-1994	Stengl et al.		

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	JP-A-61-254915	11-1986	Japan (with abstract)		
	JP-A-62-35620	02-1987	Japan (with abstract)		
	JP-A-63-185024	07-1988	Japan (with abstract)		
	JP-A-4-355419	12-1992	Japan (with abstract)		
	JP-A-5-173065	07-1993	Japan (with abstract)		
	JP-A-63-6553	01-1988	Japan		

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	English-language translation of JP-A-63-6553
	U.S. Patent Application Serial No. 08/254,780 to Miyai et al., filed June 6, 1994.
	U.S. Patent Application Serial No. 08/310,987 to Ototake et al., filed September 23, 1994.
	U.S. Patent Application Serial No. 08/360,515 to Sasaya et al., filed December 21, 1994.

EXAMINER	DATE CONSIDERED
Examiner:	Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
	5,105,075	04-1992	Ohta et al.		
	5,392,119	02-1995	McArthur et al.		
	5,308,991	05-1994	Kaplan		
	5,367,406	11-1994	Suzuki et al.		
	5,432,587	07-1995	Nozue		
	4,943,733	07-1990	Mori et al.		
	4,801,808	01-1989	Hamasaki		
	5,459,577	10-1995	Ototake et al.		
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## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	GB-A-2 138 163	10-1984	Great Britain		
	EP-A3-0 307 726	03-1989	Europe		
	EP-A1-0 660 169	06-1995	Europe		
	JP-A-59-144127	08-1984	Japan		
	JP-A-62-35619	02-1987	Japan		

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	English-language translation of JP-A-59-144127. (partial)
	English-language translation of JP-A-62-35619. (partial)

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		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
		JP-A-5-251303	09-1993	Japan (with abstract)		
		JP-A-6-5490	01-1994	Japan (with abstract)		
		JP-A-6-349702	12-1994	Japan (with abstract)		
		JP-A-63-232320	09-1988	Japan		
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		English-language translation of JP-A-63-232320.				
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	5,136,413	08-1992	MacDonald et al.		
	5,392,119	02-1995	McArthur et al.		
	4,688,904	08-1987	Hirose		
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	6,268,903	07-2001	Chiba et al.		
	6,377,333	04-2002	Chiba et al.		
	5,303,001	04-1994	Jeong et al.		
	5,995,263	11-1999	Tokuda et al.		
	6,262,793 B1	07-2001	Sasaya et al.		

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS
	GB-A-2 138 163	10-84	United Kingdom		
	EP-A2-0 307 726	03-89	Europe		
	EP-A1-0 660 169	06-95	Europe		
	JP-A-59-144127	08-1984	Japan (with abstract)		
	EP-A2-0 307 726	03-1989	Europe		

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	Numerical Recipes in C, The Art of Scientific Computing, Second Edition (1998), William H. Press et al., Cambridge University Press, New York, Chapters 16.0 and 16.1.
	"Optical Shop Testing" edited by Daniel Malacara, John Wiley & Sons, Inc. New York, Second Edition (1992), page 577.
	RMS Dictionary of Light Microscopy, S. Bradbury et al., Royal Microscopical Society (1989), Oxford University Press.
	"Technologische Möglichkeiten zur Unterdrückung der Wirkung von Oberflächenfehlern optischer Präzisionsbauelemente in Hochleistungsoptik", C. Hofmann et al., Jena; Jahrbuch für Optik und Feinmechanik 1993, p. 45-86; Fachverlag Schiele & Schön GmbH, Berlin 1993 (with translation).
	"Taschenbuch der Mathematik", I.N. Bronstein et al.; Verlag Harri Deutsch Thun und Frankfurt/Main, 22 <sup>nd</sup> ed. 1985; Chapter 7.1.2.9.1 (page 769) (with translation).
	"Synthese optischer Systeme", H. Haferkorn et al.; VEB Deutscher Verlag der Wissenschaften Berlin, 1984, pages 68-84 (with translation).

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